IN THE CLAIMS

Please amend the claims as follows:

- 1 (Currently Amended). A microcavity structure comprising two or more microcavity
- waveguides comprising photonic crystal structures, wherein one or more microcavity
- 3 active regions are created by the overlap of said microcavity waveguides and said two or
- 4 more microcavity waveguides comprise means for electrical activation and at least one
- 5 contact pad that is coupled to each of the microcavity waveguides so as to apply voltage
- 6 across said microcavity structures, wherein a top waveguide comprises p-doped or n-
- 7 doped material and a bottom waveguide comprises n-doped or p-doped material.
- 1 2 (Original). The microcavity structure of claim 1, wherein said microcavity overlap is
- 2 defined by crossing of at least two of the said microcavity waveguide at an angle.
- 1 3 (Original). The microcavity structure of claim 1, wherein each waveguide includes at
- 2 least two optical reflectors.
- 1 4 (Previously Presented). The microcavity structure of claim 3 wherein the optical
- 2 reflector component changes the direction of the incident optical energy.
- 1 5 (Original). The microcavity structure of claim 4 wherein the optical reflector could be,
- 2 but is not restricted to, a structure with a periodic change in the refractive index such as a
- 3 photonic crystal.
- 1 6 (Original). The microcavity structure of claim 3, wherein the optical reflectors surround
- 2 the active microcavity regions.

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- 1 7 (Previously Presented). The microcavity structure of claim 3, wherein one or more of
- 2 the optical reflectors define one or more output paths of the generated light.
- 8 (Original). A microcavity structure of claim 1, wherein the microcavity waveguides
- 2 provide means for material continuity to achieve the conduction of current to the active
- 3 microcavity overlap regions.
- 1 9. (Cancelled).
- 1 10 (Cancelled).
- 1 11 (Cancelled).
- 1 12 (Cancelled).
- 1 13 (Original). The microcavity structure of claim 1 further comprising a mechanism to
- 2 provide carrier confinement in the active overlap regions by converting the material
- 3 under portion of the upper waveguide into an insulator.
- 1 14 (Original). The microcavity structure of claim 1, wherein at least one of the
- 2 microcavity waveguides comprises active material used in the generation of photons.
- 1 15 (Original). A microcavity structure in claim 1, wherein the active material is
- 2 composed of quantum wells and/or quantum dots.
- 1 16 (Original). The microcavity structure of claim 1, wherein at least one of said
- 2 microcavity waveguides is used to guide light.
- 1 17 (Currently Amended). A method of forming a microcavity structure comprising:

- 2 providing two or more microcavity waveguides comprising photonic crystal
- 3 structures; and
- 4 forming one or more microcavity active regions by overlapping said microcavity
- 5 waveguides and said two or more microcavity waveguides comprise means for electrical
- 6 activation; and
- 7 providing at least one contact pad that is coupled to each of the microcavity
- 8 waveguides so as to apply voltage across said microcavity structures, wherein a top
- 9 waveguide comprises p-doped or n-doped material and a bottom waveguide comprises n-
- 10 doped or p-doped material.
- 1 18 (Original). The method of claim 17, wherein said microcavity overlap is defined by
- 2 crossing of at least two of the said microcavity waveguide at an angle.
- 1 19 (Original). The method of claim 17, wherein each waveguide includes at least two
- 2 optical reflectors.
- 1 20 (Previously Presented). The method of claim 19, wherein the optical reflector
- 2 component changes the direction of the incident optical energy.
- 1 21 (Original). The method of claim 20, wherein the optical reflector could be, but is not
- restricted to, a structure with a periodic change in the refractive index such as a photonic
- 3 crystal.
- 1 22 (Original). The method of claim 19, wherein the optical reflectors surrounds the active
- 2 microcavity regions.

- 1 23 (Previously Presented). The method of claim 19, wherein one or more of the optical
- 2 reflectors define one or more output path of the generated light.
- 1 24 (Original). A method of claim 17, wherein the microcavity waveguides provide means
- 2 for material continuity to achieve the conduction of current to the active microcavity
- 3 overlap regions.
- 1 25. (Cancelled)
- 1 26. (Cancelled)
- 1 27. (Cancelled)
- 28. (Cancelled)
- 1 29 (Original). The method of claim 17 further comprising providing a mechanism to
- 2 provide carrier confinement in the active regions by converting the material under portion
- 3 of the upper waveguide into an insulator.
- 1 30 (Original). The microcavity structure of claim 17, wherein at least one of said first
- 2 and second waveguides comprises active material used in the generation of photons.
- 1 31 (Original). A microcavity structure in claim 17, wherein the active material is
- 2 composed of quantum wells and/or quantum dots.
- 1 32 (Original). The microcavity structure of claim 17, wherein at least one of said first
- 2 and second waveguides is used to guide light.
- 1 33 (Currently Amended). A microcavity structure comprising:

a first waveguide including a first photonic crystal microcavity comprising a first
photonic crystal structure https://paped.or.n-doped.material; and
a second waveguide including a second photonic crystal microcavity comprising a

5 second photonic crystal structure <u>having n-doped or p-doped material</u>; and

a microcavity active region that is created by overlapping said first and second
microcavities; and

8 at least one contact pad that is coupled to said first waveguide and at least one
9 contact pad that is coupled to said second waveguide so as to apply voltage across said
10 microcavity structure;

wherein said first waveguide and second waveguide comprise means for electrical
 activation.

- 1 34 (Original). The microcavity of claim 33, wherein the photonic crystal surrounds the
- 2 active microcavity region.
- 1 35 (Previously Presented). The microcavity structure of claim 33, wherein one or more of
- 2 the photonic crystals define a single or multiple output path of the generated light.
- 1 36 (Original). The microcavity structure of claim 33, wherein the first and second
- 2 waveguides provide means for material continuity to achieve the conduction of current to
- 3 the active microcavity overlap region.
- 1 37. (Cancelled)
- 1 38. (Cancelled)
- 1 39. (Cancelled)

- 1 40. (Cancelled)
- 1 41 (Original). The microcavity structure of claim 33 further comprising a mechanism to
- 2 provide carrier confinement to the active region by converting the material under portion
- 3 of the upper waveguide into an insulator.
- 1 42 (Original). The microcavity structure of claim 33, wherein at least one of said first
- 2 and second waveguides is used to guide light.
- 1 43 (Original). The microcavity structure of claim 33, wherein at least one of said first
- 2 and second waveguides comprises active material used in the generation of photons.
- 1 44 (Original). The microcavity structure of claim 43, wherein said active material
- 2 comprises quantum wells and/or quantum dots.
- 1 45 (Original). The microcavity structure of claim 42, wherein said first waveguide
- 2 guides generated light and said second waveguide comprises active material used in the
- 3 generation of photons.
- 1 46 (Original). The microcavity structure of claim 45, wherein said active material
- 2 comprises quantum wells and/or quantum dots.
- 47. (Cancelled)
- 1 48. (Cancelled)

- 1 49 (Original). The microcavity structure of claim 42, wherein said second waveguide
- 2 guides generated light and said first waveguide comprises active material used in the
- 3 generation of photons.
- 1 50 (Original). The microcavity structure of claim 49, wherein said active material
- 2 comprises quantum wells and/or quantum dots.
- 1 51. (Cancelled)
- 1 52. (Cancelled)
- 53 (Currently Amended). A method of forming a microcavity structure comprising:
- 2 forming a first waveguide including a first photonic crystal microcavity having p-
- 3 <u>doped or n-doped material</u>; and
- 4 forming a second waveguide including a second photonic crystal microcavity
- 5 having n-doped or p-doped material; and
- 6 forming a microcavity active region that is created by overlapping said first layer
- 7 and second microcavities, wherein said first waveguide and second waveguide comprise
- 8 means for electrical activation; and
- 9 providing at least one contact pad that is coupled to said first waveguide and at
- 10 least one contact pad that is coupled to said second waveguide so as to apply voltage
- 11 across said microcavity structure.
 - 54 (Original). The method of claim 53, wherein the photonic crystal surrounds the active
- 2 microcavity region.

- 1 55 (Previously Presented). The method of claim 53, wherein one or more of the photonic
- 2 crystals define a single or multiple output path of the generated light.
- 1 56 (Original). The method of claim 53, wherein the first and second waveguides provide
- 2 means for material continuity to achieve the conduction of current to the active
- 3 microcavity overlap region.
- 1 57. (Cancelled)
- 1 58. (Cancelled)
- 1 59. (Cancelled)
- 1 60. (Cancelled)
- 1 61 (Original). The method of claim 53 further comprising a mechanism to provide carrier
- 2 confinement to the active region by converting the material under portion of the upper
- 3 waveguide into an insulator.
- 1 62 (Original). The method of claim 53, wherein at least one of said first and second
- 2 waveguides is used to guide light.
- 1 63 (Original). The microcavity structure of claim 53, wherein at least one of said first
- 2 and second waveguides comprises active material used in the generation of photons.
- 1 64 (Original). The microcavity structure of claim 63, wherein said active material
- 2 comprises quantum wells and/or quantum dots.

- 1 65 (Original). The microcavity structure of claim 62, wherein said first waveguide
- 2 guides generated light and said second waveguide comprises active material used in the
- 3 generation of photons.
- 1 66 (Original). The method of claim 65, wherein said active material comprises quantum
- 2 wells and/or quantum dots.
- 1 67. (Cancelled)
- 1 68. (Cancelled)
- 1 69 (Original). The method of claim 62, wherein said second waveguide guides generated
- 2 light and said first waveguide comprises active material used in the generation of
- 3 photons.
- 1 70 (Original). The method of claim 69, wherein said active material comprises quantum
- 2 wells and/or quantum dots.
- 71. (Cancelled)
- 1 72. (Cancelled)